

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor : Yasushi HAYASHIDA, et al. **CONF. NO.: 4274**

U.S. Serial No. : 10/551,225

Group Art Unit : 3651

Filed : September 28, 2005

Examiner : Ramya G. Prakasam

For : SUBSTRATE PROCESSING SYSTEM, AND METHOD OF  
CONTROL THEREFOR, CONTROL PROGRAM, AND  
STORAGE MEDIUM

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed December 19, 2008, please amend the above-identified application as set forth below and consider the following remarks.

Amendments to the Claims begin on page 2.

Remarks begin on page 4.